

Notice of References Cited	Application/Control No. 10/760,281		Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Adam C. Rehm		Art Unit 2875	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2005/0128767	06-2005	Wang et al.	362/555
	B	US-2004/0052076	03-2004	Mueller et al.	362/293
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

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